



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 16, 2024	
IGI Report Number	LG660422853
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION BRILLIANT
Measurements	8.34 X 6.30 X 4.25 MM

GRADING RESULTS

Carat Weight	1.79 CARAT
Color Grade	D
Clarity Grade	VS 2

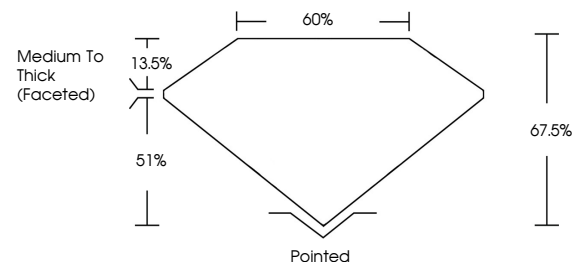
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG660422853

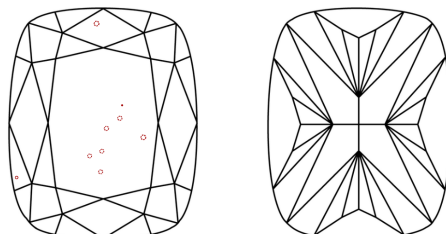
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG660422853
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VVS ^{1,2}	VS ^{1,2}	SI ^{1,2}	I ^{1,3}
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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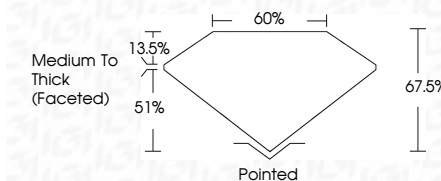
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Type IIa



October 16, 2024	GI Report No LG60402853
CUSHION BRILLIANT	
3.94 X 5.93 X 4.25 MM	1.79 CARAT
Color Grade	D
Clarity Grade	VS 2
Depth	67.5%
Table	65%
Grainle	Medium to Thick (Faceted)
Cluier	Pointed
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscriptions(s)	lg61 LG60402853
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IId	

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